



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 14, 2024	
IGI Report Number	LG659465857
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.43 X 6.70 X 4.47 MM

GRADING RESULTS

Carat Weight	2.86 CARATS
Color Grade	D
Clarity Grade	VS 1

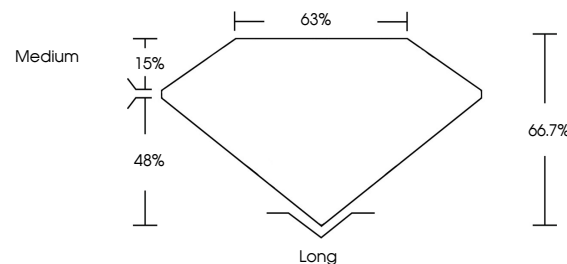
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG659465857

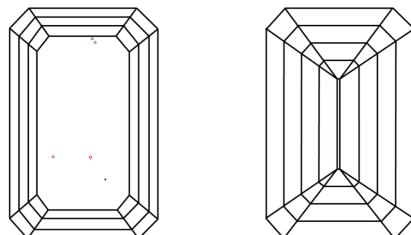
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG659465857
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ^{1,2}	VS ^{1,2}	SI ^{1,2}	I ^{1,3}
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

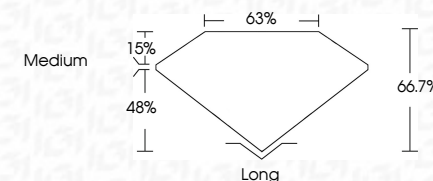
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Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG 65946585

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 IGI Report No LG659465857
 EMERALD CIT

2.66 CARATS	D	VS 1	66.7%	68%	Medium	Long	EXCELLENT	EXCELLENT	NONE
Carat Weight	Color Grade	Clarity Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence

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(CVD) growth process.

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